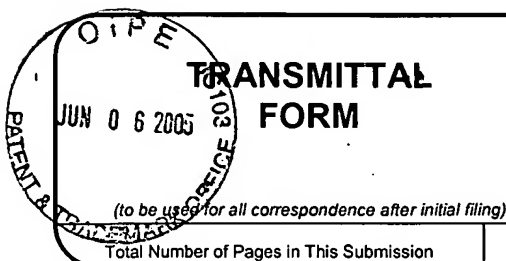


IFW

PTO/SB/21 (09-04)



Application Number	10/808,774
Filing Date	March 24, 2004
First Named Inventor	Takahashi Oeda
Art Unit	2162
Examiner Name	Jean M. Corrielus
Attorney Docket Number	16869P-009910US

**ENCLOSURES** (Check all that apply)

- |   |  |  |
|---|--|--|
| <input type="checkbox"/> Fee Transmittal Form<br><input type="checkbox"/> Fee Attached<br><input type="checkbox"/> Amendment/Reply<br><input type="checkbox"/> After Final<br><input type="checkbox"/> Affidavits/declaration(s)<br><input type="checkbox"/> Extension of Time Request<br><input type="checkbox"/> Express Abandonment Request<br><input checked="" type="checkbox"/> Information Disclosure Statement<br><br><input type="checkbox"/> Certified Copy of Priority Document(s)<br><input type="checkbox"/> Reply to Missing Parts/ Incomplete Application<br><input type="checkbox"/> Reply to Missing Parts under 37 CFR 1.52 or 1.53 | <input type="checkbox"/> Drawing(s)<br><input type="checkbox"/> Licensing-related Papers<br><input type="checkbox"/> Petition<br><input type="checkbox"/> Petition to Convert to a Provisional Application<br><input type="checkbox"/> Power of Attorney, Revocation<br><input type="checkbox"/> Change of Correspondence Address<br><input type="checkbox"/> Terminal Disclaimer<br><input type="checkbox"/> Request for Refund<br><input type="checkbox"/> CD, Number of CD(s) _____<br><input type="checkbox"/> Landscape Table on CD | <input type="checkbox"/> After Allowance Communication to TC<br><input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences<br><input type="checkbox"/> Appeal Communication to TC (Appeal Notice, Brief, Reply Brief)<br><input type="checkbox"/> Proprietary Information<br><input type="checkbox"/> Status Letter<br><input checked="" type="checkbox"/> Other Enclosure(s) (please identify below):<br>USPTO form SB08A & SB08B (two pages), copies of nine cited foreign-patent and non-patent references, copy of European Search Report for EP00119600, Return Postcard |
|---|--|--|

Remarks

The Commissioner is authorized to charge any additional fees to Deposit Account 20-1430.

**SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT**

Firm Name	Townsend and Townsend and Crew LLP		
Signature			
Printed name	Robert C. Colwell		
Date	6/1/05	Reg. No.	27,431

**CERTIFICATE OF TRANSMISSION/MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below.

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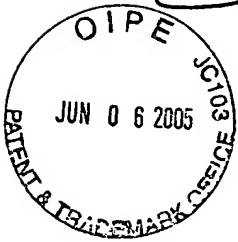
PATENT  
Attorney Docket No.: 16869P-009910US  
Client Reference No.: 349900981US2

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

On JUNE 3, 2005

TOWNSEND and TOWNSEND and CREW LLP

By: [Signature]  
Roger Hylton



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Takahashi Oeda

Application No.: 10/808,774

Filed: March 24, 2004

For: COMPUTER SYSTEM WITH  
PLURALITY OF DATABASE  
MANAGEMENT SYSTEMS

Examiner: Jean M. Corrielus

Art Unit: 2162

INFORMATION DISCLOSURE  
STATEMENT UNDER 37 CFR §1.97 and  
§1.98

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

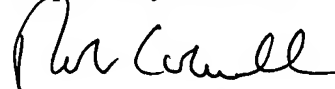
The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. Copies of the cited foreign-patent and non-patent references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

Also enclosed is a copy of the Search Report for the corresponding European patent application EP00119600.

As provided for by 37 CFR §1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,



Robert C. Colwell  
Reg. No. 27,431

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Two Embarcadero Center, Eighth Floor  
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RCC:rmh  
60502185 v1



Substitute for form 1449A/PTO <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (use as many sheets as necessary)		<b>Complete if Known</b>	
		Application Number	10/808,774
		Filing Date	March 24, 2004
		First Named Inventor	Oeda, Takahashi
		Art Unit	2162
		Examiner Name	Jean M. Corrielus
Sheet 1 of 2	Attorney Docket Number	16869P-009910US	

U.S. PATENT DOCUMENTS+					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number Kind Code <sup>2</sup> (if known)			
	1	6,509,828	01-21-2003	Bolavage et al.	
	2	2002/0029224	03-07-2002	Carlsson	
	3	6,167,405	12-26-2000	Rosensteel et al.	
	4	6,122,630	09-19-2000	Strickler et al.	
	5	5,884,028	03-16-1999	Kindell et al.	
	6	5,831,985	11-03-1998	Sandorfi et al.	
	7	5,649,168	07-15-1997	Huang et al.	
	8	5,630,067	05-13-1997	Kindell et al.	
	9	5,479,656	12-26-1995	Rawlings, III	
	10	5,457,793	10-10-1995	Elko et al.	
	11	5,006,978	04-09-1991	Neches	
	12	4,585,516	04-29-1986	Corn et al.	
	13	4,464,223	08-07-1984	Gorin.	

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)				
	14	PCT	WO99/54805	A	10-28-1999	Sun Microsystems		<input type="checkbox"/>
	15	EP	0869438	A	10-07-1998	Hitachi, Ltd.		<input type="checkbox"/>
	16	PCT	WO98/35291	A	08-13-1998	New Frame Corp.		<input type="checkbox"/>
	17	PCT	WO97/35269	A	09-25-1997	EMC Corp.		<input type="checkbox"/>

Examiner Signature		Date Considered	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Kind Codes of U.S. Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.  
60502185 v1

Substitute for form 1449B/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (use as many sheets as necessary)				<b>Complete if Known</b>	
				Application Number	10/808,774
				Filing Date	March 24, 2004
				First Named Inventor	Oeda, Takahashi
				Art Unit	2162
				Examiner Name	Jean M. Corrielus
Sheet	2	of	2	Attorney Docket Number	16869P-009910US

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T <sup>2</sup>
	18	"SAN Basics: A Technical White Paper from MetaStor Storage Solutions," LSI Logic Corporation Milpitas, CA (September 1999).		
	19	"Tegal says TEL enjoined from selling etchers with dual-frequency technology," Semiconductor Business News, <a href="http://seminews.com/sbn/sbnh2/news/19990901a1.shtml">http://seminews.com/sbn/sbnh2/news/19990901a1.shtml</a> (September 1999).		
	20	SINGER "The Challenge: Automating the Industry," Technical Program Proceedings Semicon / West 1984 San Mateo, California pp. 272-275 (May 1984).		
	21	ZAJAC et al. "Automated Plasma Etch Systems for VLSI," Technical Program Proceedings Semicon / West 1984 San Mateo, California pp 27-35. (May 1984).		
	22	ZAJAC et al. "Multi-Electrode Plasma Etching," Tegal Process Review, pp. 1-3, Tegal Corp. Petaluma, CA (May 1984).		

Examiner Signature		Date Considered	
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> Applicant is to place a check mark here if English language Translation is attached.